

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

**Kari Härkönen, Mark Doczy, Teemu Lang
and Nathan E. Baxter**

Confirmation No. 9896

Application No. 10/642,426

Filed: August 15, 2003

For: **DEPOSITION OF CARBON- AND
TRANSITION METAL-CONTAINING
THIN FILMS**

Group Art Unit: 1762

Examiner: Bret P. Chen

Date: February 21, 2006

AMENDMENT

TO THE COMMISSIONER FOR PATENTS:

This Amendment is being filed concurrently with a Request for Continued Examination.

In response to the September 21, 2005 Office action finally rejecting the pending claims, please amend the above-identified patent application as follows.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 11 of this paper.